



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

March 24, 2026	
IGI Report Number	LG784664666
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	MARQUISE BRILLIANT
Measurements	11.63 X 5.87 X 3.76 MM

GRADING RESULTS

Carat Weight	1.47 CARAT
Color Grade	D
Clarity Grade	VVS 2

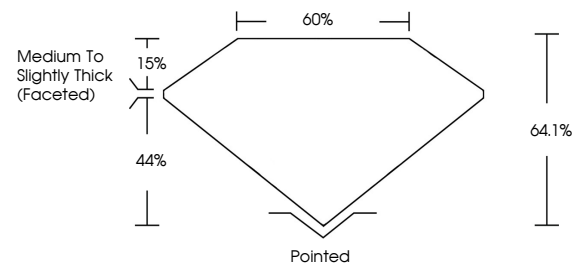
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	LG784664666

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

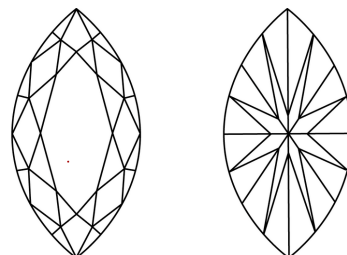
LG784664666
Report verification at igi.org

PROPORTIONS



Sample Image Used

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

COLOR

D E F G H I J Faint Very Light Light

CLARITY

FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

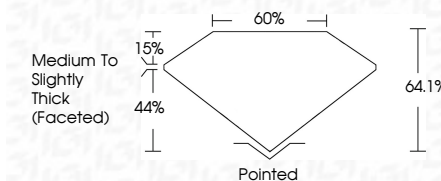
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www.igi.org

March 24, 2026	GI Report No. LG78464566	1,47 CARAT	D
MAQUINISE BRILLIANT	1.03 X 5.97 X 3.76 MM	VVS 2	64.1%
		60%	
		Medium to Slightly Thick Faceted	
		Pointed	
		EXCELLENT	
		EXCELLENT	
		NONE	
		681 LG78464566	

Comments: This is a very poor diamond was created by Chemical Vapor Deposition (CVD) growth process.

Type IIa